



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Turner et al.

Attorney Docket No.: NOVLP074

Application No.: 09/998,993

Examiner: Maldonado, Julio J.

Filed: November 15, 2001

Group: 2823

Title: Phosphorous-Doped Silicon Dioxide  
Process to Customize Etch Profiles

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the U.S. Postal Service with sufficient postage as first-class mail on June 23, 2003 in an envelope addressed to the Commissioner for Patents, P.O. Box 1450 Alexandria, VA 22313-1450.

Signed:

Latrice R. Williams

PETITION TO REVIVE UNINTENTIONALLY  
ABANDONED APPLICATION OR LAPSED PATENT  
(37 CFR 1.137(b))

Mail Stop Petition

- Commissioner for Patents
- P.O. Box 1450
- Alexandria, VA 22313-1450

Sir:

Applicant hereby petitions that the abandoned application or lapsed patent be revived. The entire delay in filing the required reply from the due date for the reply until the filing of this petition was unintentional.

The required reply ☒ is attached. ☐ has been filed.  
☐ is a continuing application which is attached.  
☐ is a Request for Continued Examination which is attached.

☐ A terminal disclaimer if required by 37 CFR 1.137(c) is attached.

☒ Check No. 7512 in the amount of \$1,300.00 for a Large Entity is enclosed for the petition fee (1.17(m)).

☒ The Commissioner is authorized to charge any fees beyond the amount enclosed which may be required, or to credit any overpayment, to Deposit Account No. 500388 (Order No. NOVLP074).

06/27/2003 AHONDAF2 00000038 09998993

01 FC:1453

1300.00 OP

P.O. Box 778  
Berkeley, CA 94704-0778  
(510) 843-6200

Respectfully submitted,  
BEYER WEAVER & THOMAS, LLP  
Roger S. Sampson  
Registration No. 44,314

RECEIVED

JUN 27 2003

OFFICE OF PETITIONS